

**Application Data Sheet****Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Masahiro
Family Name::	SAKURADA
City of Residence::	Fukushima
Country of Residence::	JAPAN

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Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Nobuaki
Family Name::	MITAMURA
City of Residence::	Fukushima
Country of Residence::	JAPAN

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Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Izumi
Family Name::	FUSEGAWA
City of Residence::	Fukushima
Country of Residence::	JAPAN

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**Correspondence Information**

Correspondence Customer Number::	25944
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**Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	AN SOI WAFER AND A METHOD FOR PRODUCING THE SAME

10/542376

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Attorney Docket Number:: 124703  
 Total Drawing Sheets:: 12  
 Small Entity:: No

**Representative Information**

James A. Oliff, Reg. No. 27,075  
 Thomas J. Pardini, Reg. No. 30,411  
 Robert A. Miller, Reg. No. 32,771  
 Kirk M. Hudson, Reg. No. 27,562

William P. Berridge, Reg. No. 30,024  
 Edward P. Walker, Reg. No. 31,450  
 Mario A. Costantino, Reg. No. 33,565

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP04/000547	01/22/2004
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-015396	01/23/2003	Yes
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-015072	01/23/2003	Yes
<b>Assignee Information</b>			
Assignee Name::		SHIN-ETSU HANDOTAI CO., LTD.	
Street of mailing address::		4-2, Marunouchi 1-chome, Chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		JAPAN	